

305-102 6p 2508

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Rhonda M. Grant

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Docket: 0756-958



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of )  
Shunpei YAMAZAKI et al. )  
Serial No. 08/183,800 ) Art Unit: 2508  
Filed: January 21, 1994 ) Examiner: M. Saadat  
For: SEMICONDUCTOR MATERIAL )  
AND METHOD FOR FORMING )  
THE SAME AND THIN FILM )  
TRANSISTOR ) Date: February 3, 1995

3/7/95  
JG  
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AMENDMENT

Honorable Commissioner of Patents and Trademarks  
Washington, D.C. 20231

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Sir:

In response to the Office Action of September 7, 1994, please amend the subject application as follows:

IN THE CLAIMS:

Cancel claims 5-14 without prejudice.

Add new claims 32-35.

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